



Inventor: 10/822,208

Title: Deposition Apparatuses

Assignee: Micron Technology, Inc.

Docket No. MI22-2519


INFORMATION DISCLOSURE STATEMENT

References – See Attached Form PTO-1449

The attached form PTO-1449 is submitted in compliance with 37 CFR § 1.56. Copies of the cited art are included with the exception of U.S. patents and published U.S. applications (1273 Off. Gaz. Pat. Off. 55, 05 August 2003). No admission is made regarding whether all the submitted references are prior art.

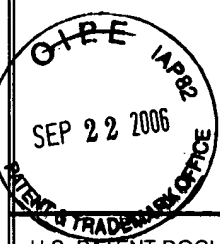
Respectfully submitted,

Dated: 9/22/06

By: 
David G. Latwesen, Ph.D.
Reg. No. 38,533

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Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-2519		SERIAL NO. 10/822,208	
 <p>LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)</p>				APPLICANT: Eric R. Blomiley, et al.			
				FILING DATE April 8, 2004		GROUP 1722	
U.S. PATENT DOCUMENTS							
*Examiner's Initials	AA	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	4,558,660	12/86	Nishizawa et al.			
	AB	5,061,872	10/91	Kulka			
	AC	5,364,667	11/94	Rhieu, Ji H.			
	AD	5,556,476	9/17/96	Lei, et al.			
	AE	6,021,152	02/00	Olsen et al			
	AF	6,108,490	06/00	Subrahmanyam et al.			
	AG	6,108,490	08/00	Lee et al.			
	AH	6,530,994	3/11/03	Mahawili			
	AI	6,994,769	2/06	Singh, et al.			
	AJ	2001/0010228	8/01	Au et al.			
	AK	2004/0000321	1/02	Cui et al.			
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
	AL						Yes No
	AM						
	AN						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
	AM						
	AN						
EXAMINER		DATE CONSIDERED					
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>							

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